

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Robert P. Fabinski, et al

VARYING FEATURE SIZE IN RESIST ACROSS THE CHIP WITHOUT THE ARTIFACT OF "GRID-SNAPPING" FROM THE MASK WRITING TOOL

Serial No. 10/706,200

Filed 12 November 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA. 22313-1450

Sir:

Group Art Unit: 2881

Examiner: Zia R. Hashmi

I hereby certify that this correspondence is being deposited today with the United States Postal Service as first class mail in an envelope addressed nissioner For Patents, P.O. Box 1450,

LETTER TO THE OFFICIAL DRAFTSPERSON

Enclosed are 2 sheets of formal drawings depicting Figure(s) 1-3. Please substitute these drawings for those currently on file in the subject application.

The Commissioner is hereby authorized to charge any fees in connection with this communication to Eastman Kodak Company Deposit Account No. 05-0225. A duplicate copy of this letter is enclosed.

Respectfully submitted,

ney for Applicant(s Registration No. 36,390

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